



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE *11-6-02*

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Applicant(s): Yoo, Woo Sik
Assignee: WaferMasters, Inc.
Title: Method For Growing Oxide Film
Serial No.: 10/085,498 Filing Date February 26, 2002
Examiner: Unassigned Group Art Unit: Unassigned
Docket No.: M-11549US

Irvine, California
October 24, 2002

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

CHANGE OF CORRESPONDENCE ADDRESS

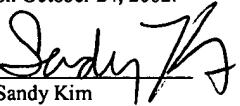
Dear Sir:

Please direct all correspondence in the above-identified application and with respect to any patent that issues on this application to the undersigned at this address:

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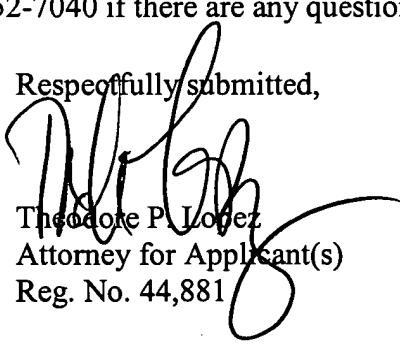
Please telephone the undersigned at (949) 752-7040 if there are any questions.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on October 24, 2002.


Sandy Kim

October 24, 2002

Respectfully submitted,


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